

Application/Control No.	Applicant(s)/Patent under Reexamination
10/791,573	KIM ET AL.
Examiner	Art Unit
Jean E. Lesperance	2629

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SEARCHED					
Class	Subclass	Date	Examiner		
345	60	7/30/2007	JL		
345	61	7/30/2007	JL		
345	62	7/30/2007	JL		
345	63	7/30/2007	JL		
345	64	7/30/2007	JL		
345	65	7/30/2007	JL		
345	66	7/30/2007	JL		
345	67	7/30/2007	JL		
345	68	7/30/2007	JL		
345	69	7/30/2007	JL		
update	search	1/10/2008	JL		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NO (INCLUDING SEARC)
	DATE	EXMR
East search and copy attached	7/30/2007	JL
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